PATTERSON&SHERIDAN

APR 1 7 2006

2004/010

PATENT
Atty. Dkt. APPM/005191.C1(Y1)/ISM/CORE/MCVD/PJS
Serial No. 10/792,323

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

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Serial No.: 10/792,323

Filed:

March 3, 2004

Confirmation No.: 4370

For:

Apparatus and Method for

Vaporizing Solid Precursor for CVD or Atomic Layer

Deposition

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Group Art Unit: 3742

Examiner:

Sang Y. Paik

MAIL STOP RCE

Commissioner for Patents P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATE OF FACSIMILE TRANSMISSION UNDER 37 CFR 1.8

I hereby certify that this correspondence and the documents referred to as attached therein are being facsimile transmitted to the U.S. Patent and Trademark Office to the fax number indicated by the Examiner, namely, fax number 571-273-8300 to the attention of the named Examiner, on the date below.

April 17, 2006

Signature

PRELIMINARY AMENDMENT

Prior to examination, please amend the above-identified application as follows. The fee for a Request for Continued Examination along with a one month extension, and a fee of \$200.00 for 1 new independent claim, has been submitted along with this paper. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/APPM/005191.C1(Y1)/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper. Remarks begin on page 6 of this paper.